

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Yi et al.

Examiner: Watson, Joy L

Serial No: 10/827,512

Group Art Unit: 1709

Filed: April 19, 2004

Docket: 8836-242 (IH13145-US)

**FOR: APPARATUS AND METHOD FOR CLEANING SEMICONDUCTOR
SUBSTRATES**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

This amendment is submitted in response to the Office Action dated February 13, 2008 in connection with the above-referenced application.